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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
09/862,894	05/22/2001	Mitsuhiro Nakamura	09792909-5022	9845	
33448 7	590 02/07/2003				
ROBERT DE	PKE	EXAM	EXAMINER		
HOLLAND + 1 55 W. MONRO	DE .	RODRIGUEZ, ISABEL			
CHICAGO, IL	60603		ART UNIT	PAPER NUMBER	
			2836	•	
		DATE MAILED: 02/07/2003			

Please find below and/or attached an Office communication concerning this application or proceeding.

<u> </u>						4/			
•		Applic	ation No.	Ap	plicant(s)				
Office Action Summary		09/862	2,894	NA	NAKAMURA ET AL.				
		Exami	n r	Ar	t Unit				
			Rodriguez	28					
1h MAIL Period for Reply	ING DATE of this communic	ation appears on	the cover si	heet with the corre	spondence add	ress			
	STATI ITODY DEDIOD EO	DEDIVIC CE	T TO EVOIS	DE 2 MONTH(C) E	:DOM				
THE MAILING D - Extrisions of time m aftr SIX (6) MONTH - If the period for reply - If I/O period for reply - Filture to reply within - My reply received by	STATUTORY PERIOD FOR ATE OF THIS COMMUNIC. The asy be available under the provisions of IS from the mailing date of this commun specified above is less than thirty (30) is specified above, the maximum statum in the set or extended period for reply will be Office later than three months after djustment. See 37 CFR 1.704(b).	ATION. 37 CFR 1.136(a). In no ication. days, a reply within the cory period will apply ar I, by statute, cause the	o event, however statutory minimund will expire SIX application to be	may a reply be timely fi m of thirty (30) days will (6) MONTHS from the m come ABANDONED (35	led be considered timely. nailing date of this com 5 U.S.C. § 133).	ımunication.			
Statu	, , , , , , , , , , , , , , , , , , , ,								
∫⊠ Responsi	ve to communication(s) filed	l on <u>22 August 2</u>	<u> 2001</u> .						
ع) This actio	on is FINAL . 2t)⊠ This action	ı is non-fina	l.					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213. psposition of Claims									
/ 4)⊠ Claim(s) <u>1</u>	1-15 is/are pending in the ap	plication.							
4a) Of the	above claim(s) is/are	withdrawn from	considerati	on.					
6)⊠ Claim(s) <u>1</u>									
7)	is/are objected to.				•				
8) Claim(s) _	are subject to restriction	on and/or electio	n requireme	ent.					
Application Papers									
9)☐ The specific	cation is objected to by the I	Examiner.							
10) The drawing	g(s) filed on <u>08/22/01</u> is/are:	a)⊠ accepted o	r b)⊡ object	ed to by the Exam	iiner.				
Applicant	may not request that any objec	tion to the drawing	g(s) be held i	n abeyance. See 3	7 CFR 1.85(a).				
11)☐ The propos	ed drawing correction filed o	on is: a)□] approved	b)□ disapproved	by the Examiner				
If approved, corrected drawings are required in reply to this Office action.									
12)⊡ The oath or	declaration is objected to b	y the Examiner.							
Priority under 35 U	.S.C. §§ 119 and 120								
13)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).									
a)⊠ All b)□ Some * c)□ None of:									
1.⊠ Cert	1. Certified copies of the priority documents have been received.								
2.☐ Cert	2. Certified copies of the priority documents have been received in Application No								
 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 									
14) Acknowledgment is made of a claim for domestic priority under 35 U.S.C. § 119(e) (to a provisional application).									
a) ☐ The translation of the foreign language provisional application has been received. 15)☐ Acknowledgment is made of a claim for domestic priority under 35 U.S.C. §§ 120 and/or 121.									
Attachment(s)		•	-						
	es Cited (PTO-892) son's Patent Drawing Review (PTC ure Statement(s) (PTO-1449) Pap		5) 🔲 N	terview Summary (PT otice of Informal Pater her:					
S Patent and Trademark Office									

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DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 2. Claims 1,4-6,9-10,13-15 are rejected under 35 U.S.C. 102(b) as being anticipated by Tsuzuki et al. (US 4,760,434).
- a) Regarding claims 1 and 5, Tsuzuki et al. discloses a protection circuit (Fig. 10) for a field effect transistor (22) for protection against a surge breakdown comprising a diode array (73) in which a plurality of forward direction first diodes and reverse direction second diodes are cascade-connected wherein a gate electrode of the FET is grounded through the diode array.
- b) Regarding claims 4 and 10, Tsuzuki et al. discloses the FET is a junction FET. See col. 3 lines 35-41.
- c) Regarding claim 6, Tsuzuki et al. discloses the semiconductor device is formed on a compound semiconductor substrate. See col. 1 lines 49-51.
- d) Regarding claim 9, Tsuzuki et al. discloses the diode includes a first conductivity type first impurity introduction layer formed in a substrate and a second conductivity type second impurity introduction layer provided opposite to the first impurity introduction. See col. 6 lines 49-53.

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e) Regarding claims 13-15, Tsuzuki et al. discloses a protection circuit (Fig. 10) for a field effect transistor (22) for protection against a surge breakdown comprising a diode array (73) in which a first diode has an anode connected to the gate electrode, a second diode has an anode connected to the cathode of the first diode, a third diode has an anode connected to the cathode of the second diode, and a fourth diode has an anode connected to the cathode of the third diode. See Fig. 10.

Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claims 2 and 7-8 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tsuzuki et al. in view of Voldman et al. (US 6,433,985).
- a) Regarding claims 2 and 8, Tsuzuki et al. discloses a protection circuit of a FET according to claim 1, wherein the diode is a silicon p-n junction diode. Tsuzuki et al. does not disclose that the diode is a Schottky diode including a Schottky electrode. Voldman et al. discloses an ESD protection circuit including diodes that can be chosen to be any commonly known diodes including Schottky diodes. It would have been obvious to one of ordinary skill in the art at the time the invention was made to use Schottky diodes because it would be equivalent

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to use the Schottky diode and thus would not affect the function of the ESD protection circuit. See col. 2 lines 36-39.

- b) Regarding claim7, Tsuzuki et al. discloses a semiconductor device as described in claim 6 with a substrate composed of Silicon. See col. 3 lines 42-45. Tsuzuki does not disclose that the substrate is made of gallium arsenate (GaAs). Voldman discloses a semiconductor composed of any semiconductor known compound such as GaAs or silicon germanium, thus establishing equivalency between both coumpounds. It would have been obvious to one of ordinary skill in the art at the time the invention was made to use GaAs instead of a silicon compound because it has been proven to be equivalent and shall not change the function of the function of the device. The selection of known equivalents would be within the level of ordinary skill in the art.
- 5. Claims 11-12 are rejected under 35 U.S.C. 103(a) as being unpatentable over Tsuzuki et al

Tsuzuki et al. discloses the semiconductor device according to claim 5 in which protection is provided to a junction field effect transistor. Tsuzuki et al. does not disclose that the FET is a Schottky barrier gate transistor nor a hetero junction field effect transistor. The examiner takes Official Notice of the equivalence of Schottky barrier gate transistor, a hetero junction field effect transistor and a field effect transistor for their use in the semiconductor protection art. It would have been obvious to one of ordinary skill in the art at the time the invention was made to use any kind of transistor in order to provide protection against ESD to any equivalent transistor.

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Conclusion

6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Isabel Rodriguez whose telephone number is 703-305-4761. The examiner can normally be reached on M-F 8:30-5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Brian Sircus can be reached on 703-308-3119. The fax phone numbers for the organization where this application or proceeding is assigned are 703-308-7724 for regular communications and 703-308-7704 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

IR January 16, 2003

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